

| Form PTO 1449 (Modified) | | U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE | | ATTY DOCKET NO. 209284US99 APPLICANT Zhiyi YU, et al. FILING DATE April 26, 2001 | | SERIAL NO. 09/842,734 GROUP 2811 | |
|---|------|--|----------|---|---|---|-------------------------------|
| LIST OF REFERENCES CITED BY APPLICANT | | | | | | | |
| U.S. PATENT DOCUMENTS | | | | | | | |
| EXAMINER INITIAL | | DOCUMENT NUMBER | DATE | NAME | CLASS | SUB CLASS | FILING DATE IF APPROPRIATE |
| SR | ZV | 5,122,679 | 06/16/92 | ISHII ET AL | | | |
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| SR | CCS | WO 99/67882 | 12/29/99 | WIPO | | | |
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| SR | LLAP | YI W. et al; "Mechanism of cleaning Si (100) surface using Sr and SrO for the growth of crystalline SrTiO/sub 2/films" Journal of Vacuum Science & Technology, Vol. 20, No. 4, July 2002 (2002-07) pp. 1402-1405 | | | | | |
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| Examiner <i>Shoun...</i> | | | | | <input type="checkbox"/> Additional References sheet(s) attached Date Considered <i>12/16/04</i> | | |

*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.